



**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

*Please Enter  
Tm 1/3/05*

**In re Application of:**

**Sandhu et. al.**

**Serial No.: 10/642,705**

**Filed: August 18, 2003**

**For: PROCESS FOR GROWING A  
DIELECTRIC LAYER ON A SILICON  
CONTAINING SURFACE USING A  
MIXTURE OF N<sub>2</sub>O AND O<sub>3</sub>**

**Confirmation No.: 4361**

**Examiner: T. Meeks**

**Group Art Unit: 1762**

**Attorney Docket No.: 2269-3980.3US  
(92-0094.02/US)**

**Notice of Allowance Mailed:**

**September 3, 2004**

**Express Mail Mailing Label No.: EL 994828583 US**

**Date of Deposit with USPS: December 3, 2004**

**Person making Deposit: Steve Wong**

**AMENDMENT PURSUANT TO 37 C.F.R. § 1.312(a)**

Mail Stop ISSUE FEE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Sir:

Please amend the above-referenced application as follows: